


<b>Search Notes</b>  	<b>Application/Control No.</b>  10024222	<b>Applicant(s)/Patent Under Reexamination</b>  JUNG, JIN HEE
	<b>Examiner</b>  Fineman, Lee	<b>Art Unit</b>  2872

SEARCHED			
Class	Subclass	Date	Examiner
359	462,464,465	2/4/03	LAF
348	57,58	2/4/03	LAF
349	15	2/4/03	LAF
UPDATE	SEARCH	7/22/03	LAF
UPDATE	SEARCH	2/10/04	LAF
UPDATE	SEARCH	10/1/04	LAF
UPDATE	SEARCH	5/12/05	LAF
UPDATE	SEARCH	10/28/05	LAF
UPDATE	SEARCH	2/15/06	LAF
UPDATE	SEARCH	1/5/07	LAF
UPDATE	SEARCH	6/6/07	LAF

SEARCH NOTES		
Search Notes	Date	Examiner
Consulted A. Chang, AU 2872 for search	2/4/03	LAF
See East Search Attached	2/5/03	LAF
East Search Attached	10/1/04	LAF
Consulted Arnel Lavarias for 112 rejection	7/15/06	JP
Update Search	7/15/06	JP
East Search (see search history printout)	6/6/07	LAF

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner